



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

17/Amend 2
P. Walker
3-21-02

Application Serial No. 09/512,968
Filing Date February 24, 2000
Inventor David R. Hembree
Assignee Micron Technology, Inc.
Group Art Unit 2832
Examiner V. Nguyen
Attorney's Docket No. MI22-1363
Title: "Wafer Processing Apparatuses and Electronic Device Workpiece Processing
Apparatuses (As Amended)"

RESPONSE TO OCTOBER 26, 2001 OFFICE ACTION

To: Assistant Commissioner for Patents
Washington, D.C. 20231

EL 844054260

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
Wells, St. John, Roberts, Gregory & Matkin P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

Sir:

Responsive to the Office Action dated October 26, 2001, Applicant amends and
remarks as follows:

AMENDMENTS

In the Claims

Please replace the claims with the following clean version of the entire set of
pending claims, in accordance with 37 C.F.R. § 1.121(c)(1)(I).

A marked up version showing amendments to any claims being changed is provided
in one or more accompanying pages separate from this amendment in accordance with 37
C.F.R. § 1.121(c)(1)(ii).

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